



Appl. No. 10/075,193

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/075,193  
Filing Date ..... February 13, 2002  
Inventor..... Shenlin Chen et al.  
Assignee..... Micron Technology, Inc.  
Group Art Unit..... 2813  
Examiner ..... Huynh, Y.  
Attorney's Docket No. .... MI22-1927  
Title: Methods of Forming a Capacitor Structure

*cc. 42-60*

**RESPONSE TO AUGUST 19, 2002 OFFICE ACTION**

To: Non-Fee Amendment  
Assistant Commissioner for Patents  
Washington, D.C. 20231

From: Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)  
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**AMENDMENTS**

**In the Claims**

Please replace the indicated claims with the following clean versions of the claims, in accordance with 37 C.F.R. § 1.121(c)(1)(i). Cancel all previous versions of any indicated claim. A marked up version showing amendments to any claims being changed is provided in one or more accompanying pages separate from this amendment in accordance with 37 C.F.R. § 1.121(c)(1)(ii). Any claim not accompanied by a marked up version has not been changed relative to the immediate prior version, except that marked up versions are not being supplied for any added claim or canceled claim.